



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 8, 2025

IGI Report Number **LG755520760**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **MARQUISE BRILLIANT**

Measurements **12.81 X 6.44 X 4.01 MM**

GRADING RESULTS

Carat Weight **1.86 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

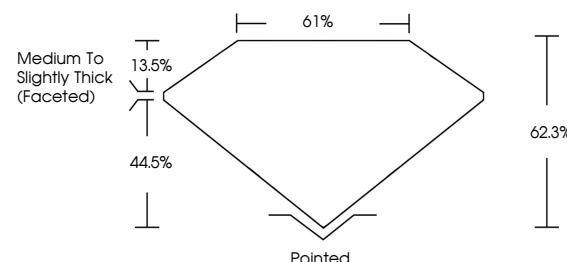
Symmetry **EXCELLENT**

Fluorescence **NONE**

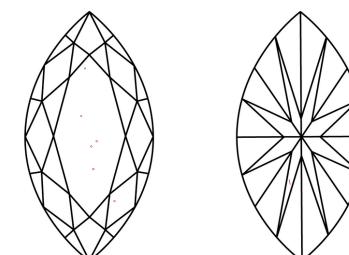
Inscription(s) **IGI LG755520760**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

LG755520760
Report verification at igi.org

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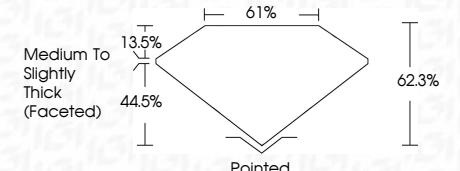
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Sample Image Used



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December 8, 2025	IGI Report No LG755520760	MARQUISE BRILLIANT	1.86 CARAT	E	VS 1	62.3%	61.5%	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG755520760
				Carat Weight	Color Grade	Depth	Table	Grade	Polish	Symmetry	Fluorescence	Inscription(s)
				1.86 CARAT	E	62.3%	61.5%	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG755520760
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